

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of: W. SCHWARZENBACH et al. Confirmation No.: 9739  
Application No.: 10/733,729 Group Art Unit: 2818  
Filing Date: December 12, 2003 Examiner: David Nhu  
For: METHOD OF MAKING CAVITIES IN A Attorney Docket No.: 4717-9200  
SEMICONDUCTOR

**SUBMISSION OF FORMAL DRAWINGS**

**Mail Stop Issue Fee**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

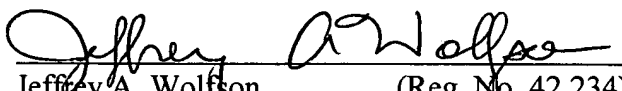
Sir:

In response to the Notice of Allowability mailed August 11, 2005, submitted herewith is a copy of one (1) sheet of replacement formal drawings including Figs. 3A, 3B, 3C and 5. Applicants respectfully request that the attached sheet of replacement drawings be substituted for the annotated drawings filed on July 27, 2005 and approved by the Examiner on August 11, 2005.

No fee is believed to be due for this submission. Should any fees be required, however, please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

8/26/05  
\_\_\_\_\_  
Date

  
Jeffrey A. Wolfson (Reg. No. 42,234)

**WINSTON & STRAWN LLP**  
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